504405903 06/09/2017

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
HIROYUKI SATAKE	05/17/2017
HIDEKI HASEGAWA	05/08/2017
MASAO SUGA	04/28/2017
YUICHIRO HASHIMOTO	05/08/2017

RECEIVING PARTY DATA

Name:	HITACHI HIGH-TECHNOLOGIES CORPORATION
Street Address:	24-14, NISHI SHIMBASHI 1-CHOME, MINATO-KU,
City:	TOKYO
State/Country:	JAPAN

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	15534607

CORRESPONDENCE DATA

Fax Number: (703)684-1157

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 703-684-1120

Email: svannarath@mmiplaw.com
Correspondent Name: MATTINGLY & MALUR, PC
Address Line 1: 1800 DIAGONAL ROAD

Address Line 2: SUITE 210

Address Line 4: ALEXANDRIA, VIRGINIA 22314

ATTORNEY DOCKET NUMBER:	H&A-11000
NAME OF SUBMITTER:	SHRINATH MALUR
SIGNATURE:	/Shrinath Malur/
DATE SIGNED:	06/09/2017

Total Attachments: 4

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(譲渡証)

As a below named inventor, I hereby declare that:

IN CONS!DERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by HITACHI HIGH-TECHNOLOGIES CORPORATION, a corporation organized under the laws of Japan,

located at 24-14, Nishi Shimbashi 1-chome, Minato-ku, Tokyo, Japan, receipt of which is hereby acknowledged I do hereby sell and assign to said HITACHI HIGH-TECHNOLOGIES CORPORATION.

its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

MASS SPECTROMETER

invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, No. PCT/JP2014/084054 filed December 24, 2014, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted,

to be held and enjoyed by said HITACHI HIGH-TECHNOLOGIES CORPORATION.

its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made:

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said HITACHI HIGH-TECHNOLOGIES CORPORATION.

Signed on the date(s) indicated aside our signatures:

(発明者フルネームサイン)		Date Signed (署名日)	
1)	Hiroyuki Satake Hiroyuki SATAKE	05/17/2017	
2)	Hideki HASEGAWA	· · · · · · · · · · · · · · · · · · ·	
3)	Masao SUGA	·	
4)	Yuichiro HASHIMOTO		

PATENT REEL: 042658 FRAME: 0927

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Signed on the date(s) indicated aside our signatures:

INVENTOR(S)

(発明者フルネームサイン) (署名目)

1) Hiroyuki SATAKE

2) Zicileki Zhusugawa Hideki HASEGAWA 5 / 8 / 2017

3) Masac SUGA

Yuichiro HASHIMOTO

PATENT REEL: 042658 FRAME: 0928

Date Signed

(譲渡証)

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Signed on the date(s) indicated aside our signatures:

Date Signed (署名日)	INVENTOR(S) (発明者フルネームサイン)	
	Hiroyuki SATAKE	1)_
	Hideki HASEGAWA	2)_
04/28/2017	Masao Suga Masao SUGA	3)_
	Yuichiro HASHIMOTO	4)

PATENT REEL: 042658 FRAME: 0929

(譲渡証)

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(発明者フルネームサイン)	(署名日)
1)	Hiroyuki SATAKE	*
2)	Hideki HASEGAWA	
3)	Masao SUGA	
av Gul	w/hid Vulchiro HASHIMOTO	5/8/2017

PATENT REEL: 042658 FRAME: 0930

Date Staned

RECORDED: 06/09/2017